

Fig. 1

Appln No.: 10/826,920 P
Applicant(s): Shunpei Yamazaki et al.
AN APPARATUS FOR FORMING A FILM AND AN
ELECTROLUMINESCENCE DEVICE

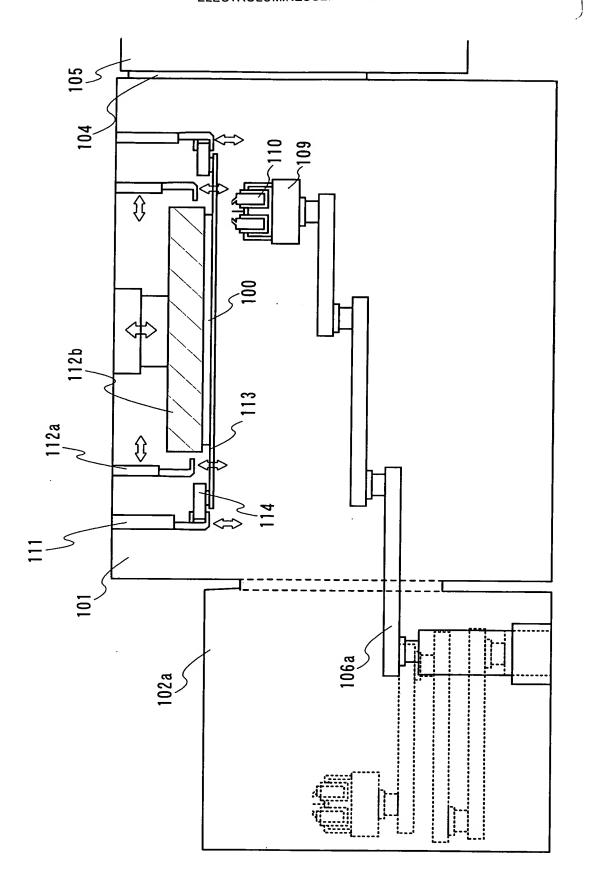
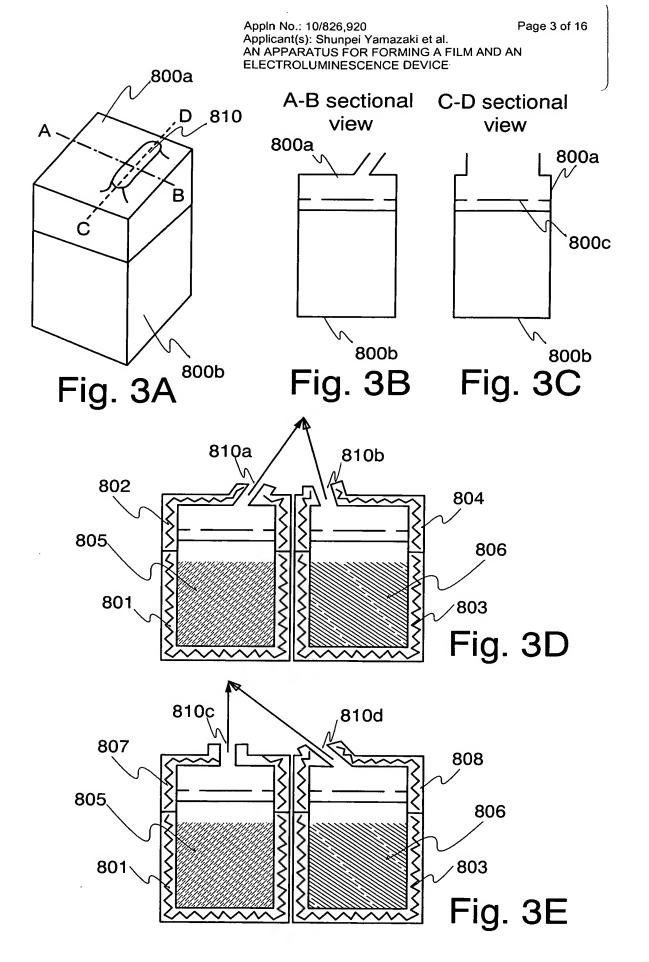


Fig. 2



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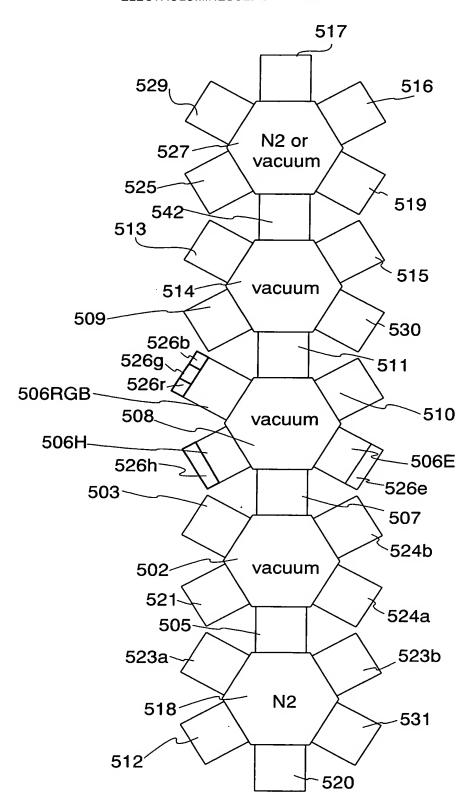
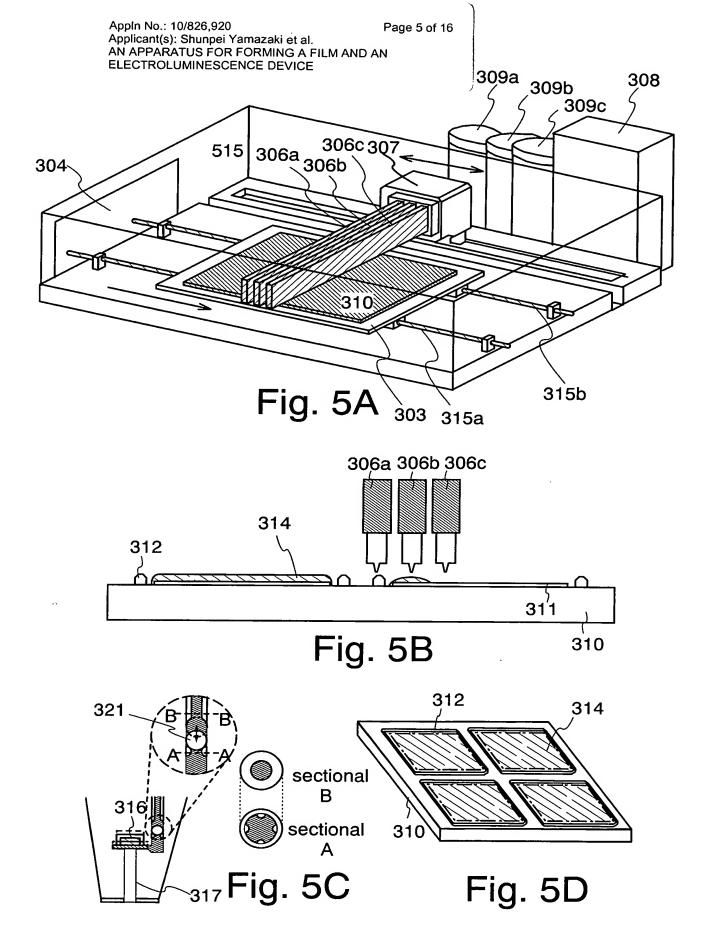
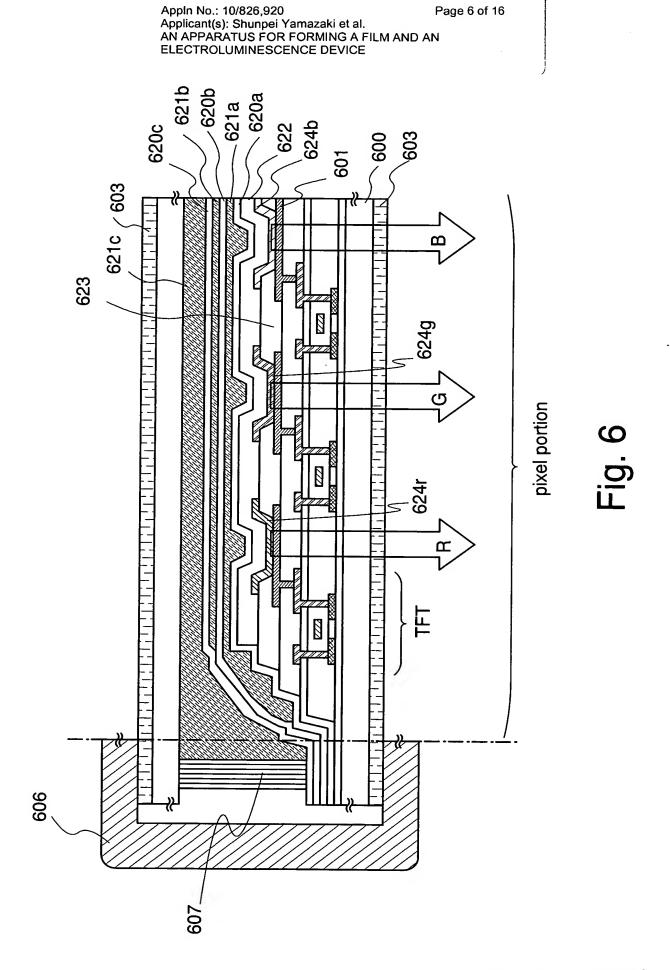
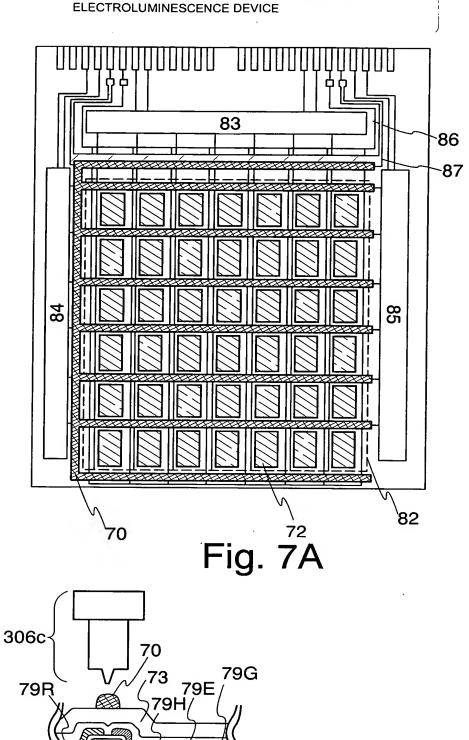


Fig. 4





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evaporation applied to a test substrate using an evaporation maker



positional measurement of an evaporation pattern



to create a corrected data according to the evaporation pattern



setting an exposure position of stepper on the basis of the corrected data



starting manufacturing an active matrix substrate

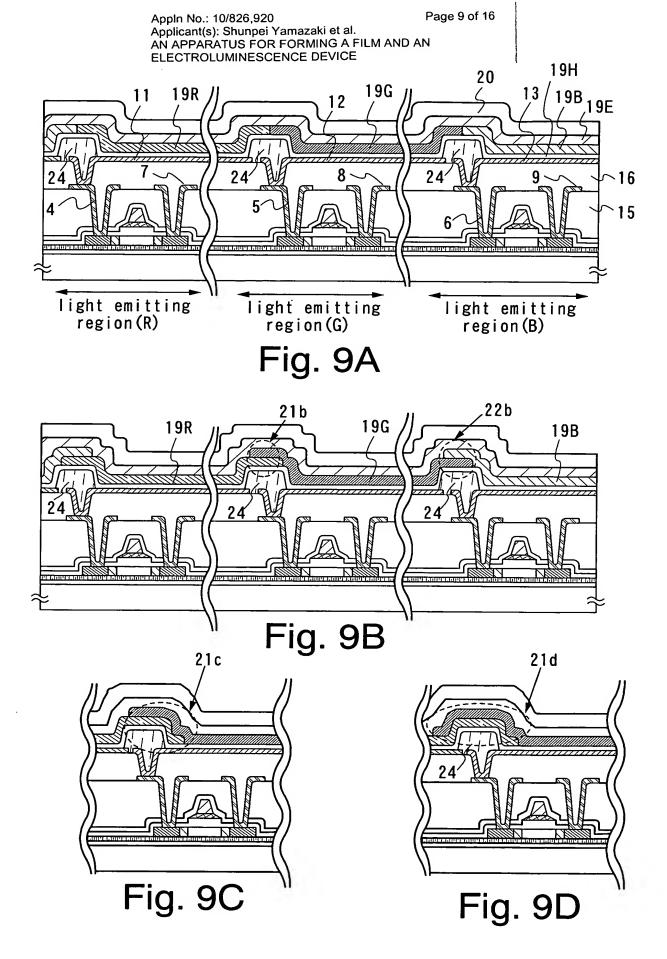


forming a TFT and an anode (or cathode) (including a step of patterning using stepper exposure)



evaporation adjusting on the basis of the evaporation maker

Fig. 8



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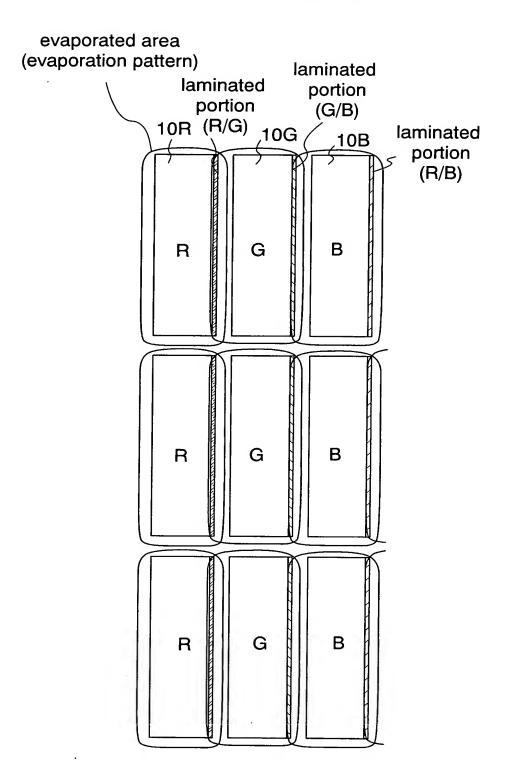
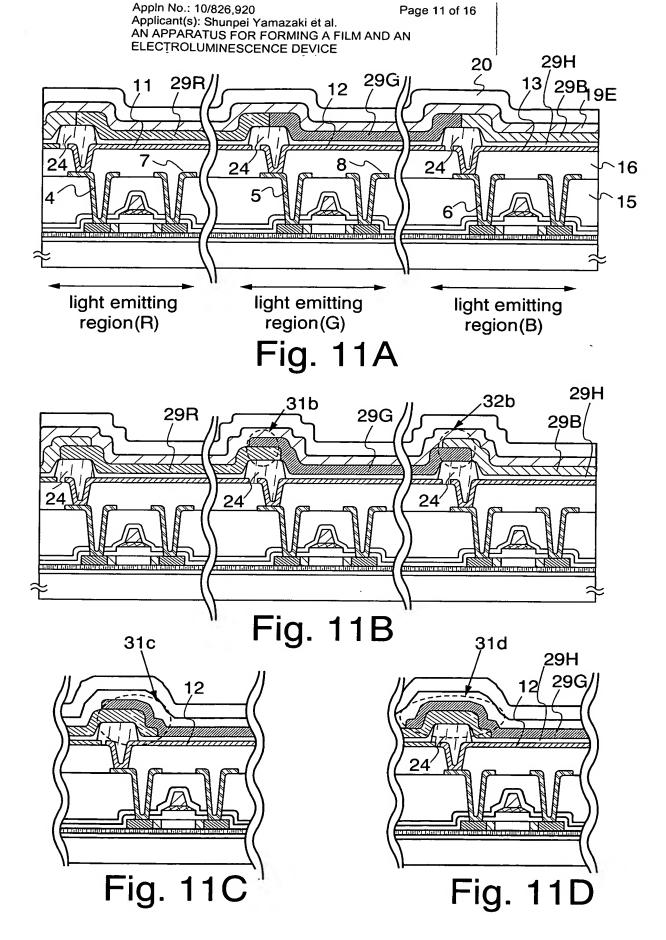
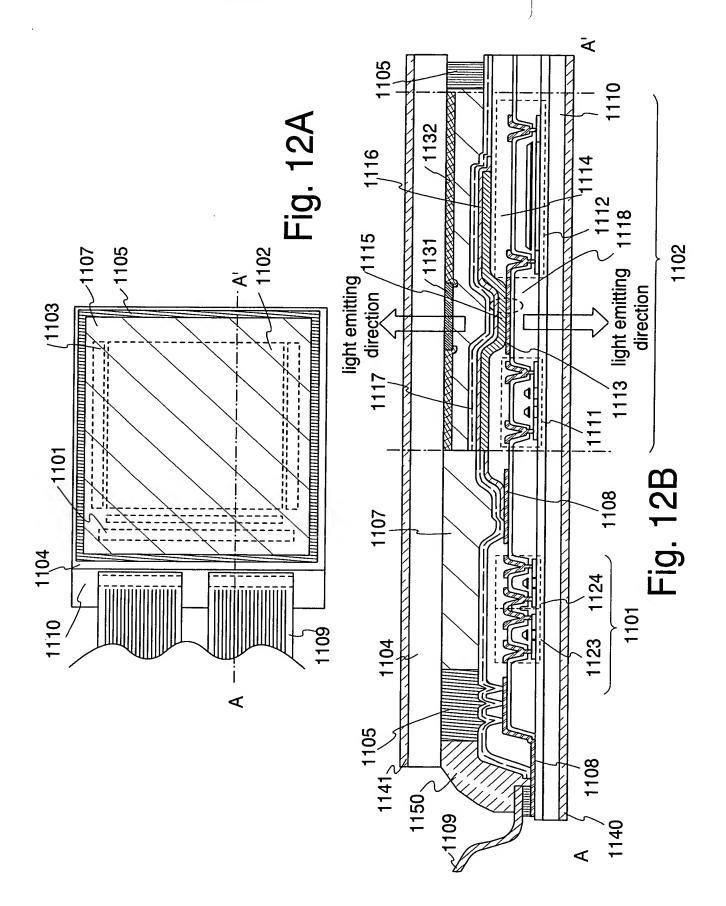
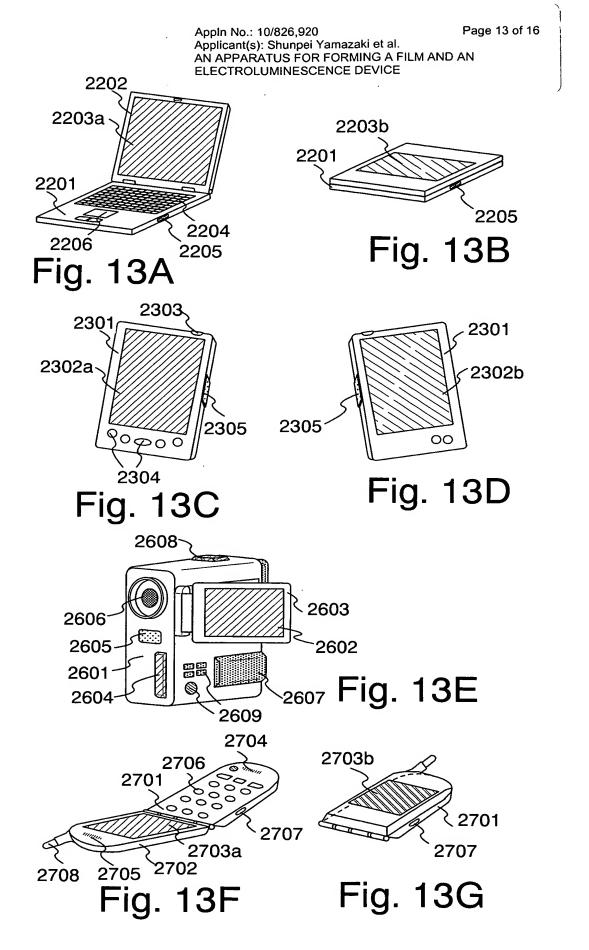


Fig. 10



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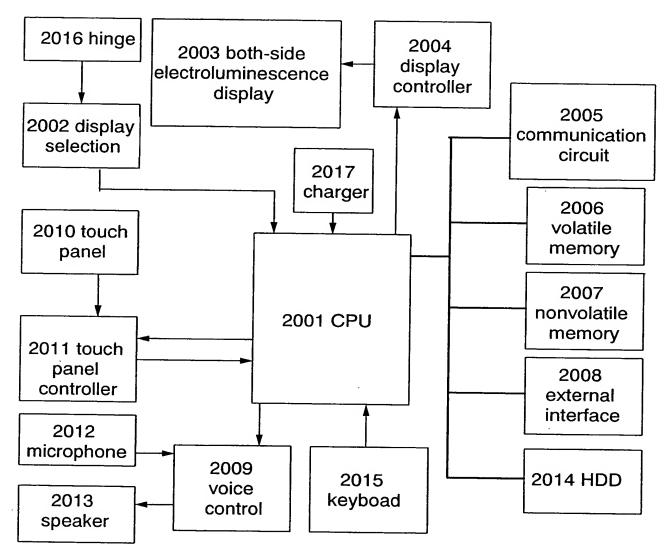


Fig. 14

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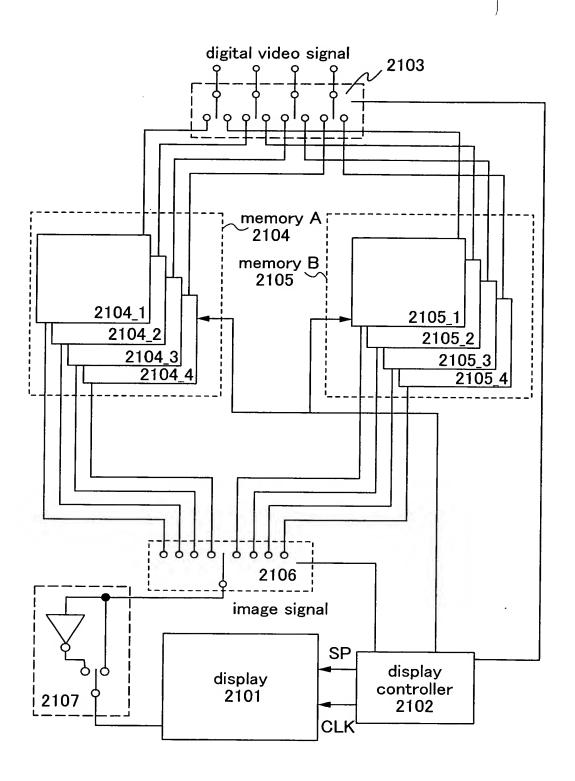


Fig. 15

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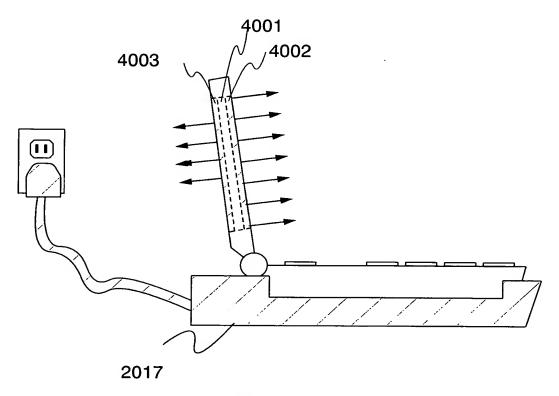


Fig. 16